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PTO/SB/08A (08-00)

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	09/710,628
Filing Date	11/08/2000
First Named Inventor	Kang
Group Art Unit	2812
Examiner Name	Unassigned
Attorney Docket Number	18419008210

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
SM	1	6,214,701	B1	Matsushita et al.	04-10-2001	
	2	6,204,151	B1	Malik et al.	03-20-2001	
	3	6,162,705		Henley et al.	12-19-2000	
	4	6,143,628		Sato et al.	11-07-2000	
	5	6,107,213		Tayanaka	08-22-2000	
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	7	5,966,625		Zhong et al.	10-12-1999	
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	11	5,841,931		Foresi et al.	11-24-1998	
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	14	5,518,965		Menigaux et al.	05-21-1996	
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	16	5,427,052		Ohta et al.	06-27-1995	
	17	5,409,563		Cathey	04-25-1995	
	18	4,530,149		Jastrzebski et al.	07-23-1985	

FOREIGN PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
SM	19	EP	905 767	A1		03-31-1999		
	20	EP	553 852	A2		08-04-1993		
	21	EP	961 312	A2		12-01-1999		
	22	JP	2000-94317	A		04-04-2000		Abst. only

Examiner Signature

Date Considered

2/18/2002

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/710,628
		Filing Date	11/08/2000
		First Named Inventor	Kang
		Group Art Unit	2812
		Examiner Name	Unassigned
		Attorney Docket Number	18419008210

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SW	23	MORICEAU et al., "Hydrogen annealing treatment used to obtain high quality SOI surfaces," <u>Proceedings of 1998 IEEE Int. SOI Conference</u> , pages 37-38 from conference held October 5-8, 1998.	
	24	SATO et al., "Suppression of Si etching during hydrogen annealing of silicon-on-insulator," <u>Proceedings of 1998 IEEE Int. SOI Conference</u> , pages 17-18 from conference held October 5-8, 1998.	
SW	25	TATE et al., "Defect reduction of bonded SOI wafers by post anneal process in H/sub 2/ ambient," <u>Proceedings of 1998 IEEE Int. SOI Conference</u> , pages 141-142 from conference held October 5-8, 1998.	

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